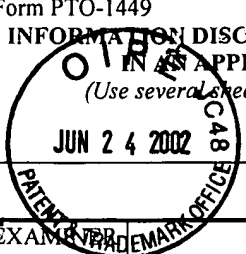




Form PTO-1449 <b>INFORMATION DISCLOSURE CITATION</b> <b>IN AN APPLICATION</b> <i>(Use several sheets if necessary)</i>		Docket Number (Optional) KHEN-P01-001		Application Number 09/839,485		
		Applicant Lavoie et al.		Group Art Unit 2644		
		Filing Date April 20, 2001				
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
m	AA 5,481,615	1/2/96	Eatwell et al.			
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES      NO
m	AB JP 10136498	5/22/98	Japan			Abstract
2	AC WO 97/40642	10/30/97	PCT			
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages Etc.)</i>						
		<div style="font-size: 1.5em; font-weight: bold;">RECEIVED</div> <div style="font-weight: bold;">JUN 27 2002</div> <div style="font-weight: bold;">Technology Center 2600</div>				
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